

08 MAR 2001

09/743545

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant	:	Thomas Jung	:
Serial No.	:	09/743,545	:
International Serial No.	:	PCT/EP99/05409	:
International Filing Date	:	July 28, 1999	:
Priority Date	:	July 31, 1998	:
Attny No.	:	65,243,001	:
Title	:	DEVICE AND METHOD FOR THE	:
		VACUUM PLASMA PROCESSING	:
		OF OBJECTS	:

**INFORMATION DISCLOSURE STATEMENT**  
**UNDER 37 CFR 1.97 AND 1.98**

Assistant Commissioner for Patents  
Washington, D.C. 20231  
**Box DD**

Sir:

Pursuant to Rule 97 and in compliance with Rule 56, Applicant hereby makes of record the items listed on the attached Form PTO-1449. Copies of the listed items are enclosed.

None of these items discloses the inventive concepts claimed in the subject application.

Should there be a fee associated with this document, please charge it to Deposit Account No. 08-2789. A duplicate of this paper is enclosed.

**Respectfully submitted,**

**HOWARD & HOWARD ATTORNEYS, P.C.**

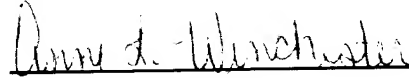
3/8/01  
**Date**

  
**Harold W. Milton, Registration No. 22,180**  
The Pinehurst Office Center, Suite #101  
39400 Woodward Ave.  
Bloomfield Hills, MI 48304-5151  
(248) 723-0352

Enclosures:  
PTO-1449 w/ 5Cited References

**CERTIFICATE OF EXPRESS MAILING**

I hereby certify that the enclosed paper or fee is being deposited with the United States Postal Service as Express Mail, postage prepaid, in an envelope as "Express Mail Post Office to Addressee", Mailing Label No. **EL726039419US** and addressed to the Assistant Commissioner of Patents, Washington, D. C. 20231, on **March 8, 2001**.



Anne L. Winchester